Attorney Docket No. P132-US

#### **TENT AND TRADEMARK OFFICE** IN THE UNITED STATES PA

In re Application of:

Jim Dunphy, et a

Serial No.:

10/811,449

Filed: 3/26/04

Art Unit: Not Yet Assigned

Examiner: Not Yet Assigned

METHOD AND APPARATUS FOR LUBRICATING MICROELECTROMECHANICAL For: **DEVICES IN PACKAGES** 

### INFORMATION DISCLOSURE STATEMENT PURSUANT TO 37 CFR 1.97(b)

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

The attention of the Patent and Trademark Office is hereby directed to the following documents: Copies of cited references are enclosed.

No fee or certification is required in connection with this Information Disclosure Statement, since it is being submitted prior to the last of (1) issuance of a first official action on the merits and (2) expiration of the three month period following filing of the above-captioned application.

The above information is presented so that the Patent and Trademark Office can determine any materiality thereof to the claimed invention. It is respectfully requested that the information be considered during the prosecution of this application and that the cited documents be listed on the front page of any patent issuing from this application.

The Patent Office is authorized to charge our Deposit Account No. 501516 for any fee which it deems to be required to effect consideration of this statement.

Respectfully submitted,

Gregory R. Myir

Attorney for Applicant(s) Registration No. 35,293

REFLECTIVITY, INC. 350 Potrero Avenue Sunnyvale, CA 94085

Tel: 408) 737-8100 x. 136

Fax: 408-737-8153

#### ATTY. DOCKET NO. SERIAL NO. INFORMATION DISCLOSURE P132-US 10/811,449 CITATION APPLICANT Dunphy, et al. APR 2 8 2005 **ETO-1449** GROUP Not Yet Assigned FILING DATE 3/26/04 SHEET 1 OF 2 U.S. PATENT DOCUMENTS PATENT NO. **CLASS SUBCLASS** FILING DATE DATE **EXAMINER'S** NAME **INITIALS** 5,939,785 8/17/99 Klonis, et al. 5,411,769 8/17/99 Hornbeck 6,204,085 3/20/01 Strumpell, et al. 2003/0064149 4/3/03 Miller 6,259,551 7/10/01 Jacobs 9/5/95 Webb 5,447,600 6,300,294 10/9/01 Robbins, et al. 7/11/00 Renk, et al. 6,086,726 11/5/02 6,475,570 Jacobs 2004/0100677 5/27/04 Huibers, et al. 2004/0125346 7/1/04 Huibers FOREIGN PATENT DOCUMENTS TRANSLATION EXAMINER'S PATENT NO. COUNTRY **CLASS SUBCLASS** DATE

<b>1</b>							1 20					
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)												
	W. Robert Ashurst, et al., WAFER LEVEL ANTI-STICTION COATINGS FOR MEMS., Sensors and Actuators A 104 (2003), Pgs 213-221.											
	W. Robert Ashurst et al., VAPOR PHASE ANTI-STICTION COATINGS FOR MEMS, Pgs 1-6.											
	W. Robert Ashurst AND SUPERIOR							TION				
	B.C. Bunker, et a DEPOSITION O											
<i>J</i> 1	Pgs 7742-7751.				-							
	W. Robert Ashurst COATINGS FOR						ON					
	S Imad-Uddin Al FRICTION AND	, ,						CE				
	Uthara Srinivasan, et al., SELF ADDRESSED FLUOROCARBON FILMS FOR ENHANCED STICTION REDUCTION, 1997 ieee, Pgs. 1399-1402.											

YES

NO

**INITIALS** 

**EXAMINER** 

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

DATE CONSIDERED

# **ÖRMATION DISCLOSURE CITATION**

PTO-1449

ATTY. DOCKET NO. P132-US

SERIAL NO. 10/811,449

APPLICANT Dunphy, et al.

SHEET 2 OF 2			FILING DATE 3/26/04		GROUP Not Yet Assigned				
		U.S. P	ATENT DOCUMENTS						
EXAMINER'S INITIALS	PATENT NO.	DATE	NAME	CLASS	S SUBCLASS	FILING DATE			
	2004/0012838	1/22/04	Huibers						
	2004/0100594	5/27/04	Huibers, et al.						
	2004/0156090	8/12/04	Patel, et al.						
	5,835,256	11/10/98	Huibers						
	6,046,840	4/4/00	Huibers						
	6,844,959	1/18/05	Huibers, et al.						
	6,867,897	3/15/05	Patel, et al.						
	5,287,096	2/15/94	Thompson, et al.						
		FOREIC	ON PATENT DOCUMENT	S					
EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS SUBCLASS		TRANSLATION			
						YES	NO		
	OTHER DOC	UMENTS (Inc	luding Author, Title, Date,	Pertinen	t Pages, Etc.)				
	•								
EXAMINER		DATE CONSIDERED							

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line thro



Under the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it contains a valid OMB control number.

## Certificate of Mailing under 37 CFR 1.8

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to:

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

on 4/20/05

Signature

Dawn Rose

Typed or printed name of person signing Certificate

Note: Each paper must have its own certificate of mailing, or this certificate must identify each submitted paper.

Information Disclosure Statment- 4 pgs Rtn postcard

Attorney Docket No. P132-US -Serial No.10/811,449

conies of Rets

This collection of information is required by 37 CFR 1.8. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 1.8 minutes to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.